

**RESPONSE UNDER 37 C.F.R. § 1.111
EXAMINING GROUP 1765**

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of : K.R. Udayakumar et al. Confirmation No.: 8320
Application Number : 10/721,932
Filed : November 25, 2003
Title : METHOD FOR ETCHING A SUBSTRATE AND A DEVICE
FORMED USING THE METHOD
TC/Art Unit : 1765
Examiner: : Lan VINH

Docket No. : TI-35507 (0025.0203)
Customer No. : **23494**

MAIL STOP AMENDMENT
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

AMENDMENT AND RESPONSE TO OFFICE ACTION

Responsive to the Office Action mailed September 27, 2007, and pursuant to
37 C.F.R. § 1.111, please amend this application as follows:

Current Claims are reflected in the listing of claims in this paper beginning at
page 2.

Remarks begin at page 8.